

Confirmation No. 3317

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Detecheverry, Celine	Examiner:	Baisa, Joselito
Serial No.:	10/564,582	Group Art Unit:	2832
Filed:	January 12, 2006	Docket No.:	NL030878US
Title:	INDUCTIVE AND CAPACITIVE ELEMENTS FOR SEMICONDUCTOR TECHNOLOGIES WITH MINIMUM PATTERN DENSITY REQUIREMENTS		

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**OFFICE ACTION RESPONSE AND AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Customer No. <b>65913</b>
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Dear Sir:

In response to the non-final Office Action dated October 18, 2007, please reconsider the application in view of the following amendments and remarks.

A complete listing of the claims, to include any amendments presented therein, begins on page 2 of this paper.

Remarks/Arguments follow on page 6.

**Authorization is provided to charge/credit Deposit Account 50-0996 (NXPS.267PA) any requisite fees/overages to enter this paper.**